

<b>Notice of References Cited</b>	Application/Control No. 10/564,404	Applicant(s)/Patent Under Reexamination LEE, SUK-HUN	
	Examiner Scott R. Wilson	Art Unit 2826	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,906,352	06-2005	Edmond et al.	257/94
*	B	US-6,201,262	03-2001	Edmond et al.	257/77
*	C	US-6,015,979	01-2000	Sugiura et al.	257/86
*	D	US-6,657,234	12-2003	Tanizawa, Koji	257/79
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP02002016284A	01-2002	Japan	Suzuki et al.	H01L033/00
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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